

REMARKS/ARGUMENTS

The Examiner's attention to the present application is noted with appreciation.

On page 2, first paragraph, of the Office Action dated January 20, 2004, the Examiner rejected claims 1-18 under 35 U.S.C. § 112, second paragraph. The Examiner stated that claims are indefinite because it is not clear whether the two layers of the film are the electrode, part of the electrode, or distinct from the electrode. The examiner stated that the claims do not indicate which layers are "etch-processed". Claim 1 has been amended to state that the thin layer is etch-processed and forms the electrode and that the electrode is disposed adjacent to the two the conductive layer and to the dielectric layer. The amended language of claim 1 has been incorporated into the allowable claims as discussed below. The Examiner also noted that the substrate mentioned in claim 11 has no antecedent basis in claims 1 or 10, but would if dependent on claim 8. Therefore, claim 11 has been amended to depend on claim 8.

On page 4, first full paragraph, the Examiner stated that claims 3, 4, 10, 15, 17, and 18 would be allowable if rewritten. Claim 1 has been amended to include the language of claim 3, and claim 3 has been cancelled. Claim 2, being broader than the amended claim 1, has been cancelled. Claim 4, has been amended to depend on claim 1 rather than on claim 3.

New claims 20, 21, and 22 incorporate the language of original claims 10, 11, and 15, respectively. The language of original claim 18, which is dependent on claim 17, has been incorporated into new claim 23, which is dependent on claim 22.

The Examiner also objected to the specification stating that, on page 7 of the specification, reference is made to "Fig. 1" although the specification contains Figs. 1(a) and 1(b). The specification is amended to replace the reference to "Fig. 1" with a reference to "Figs. 1(a) and 1(b)".

In view of the above amendments and remarks, it is respectfully submitted that all grounds of rejection and objection have been traversed. It is believed that the application is now in condition for allowance and same is respectfully requested.

If any issues remain, or if the Examiner believes that prosecution of this application might be expedited by discussion of the issues, the Examiner is cordially invited to telephone the undersigned attorney for Applicant at the telephone number listed below.

Patent Application No. 10/056,736

Authorization is given to charge payment of any additional fees required to Deposit Acct. 13-4213.

Respectfully submitted,

By:


Vidal A. Oaxaca, Reg. No.44,267
Direct line: (505) 998-1505

PEACOCK, MYERS & ADAMS, P.C.
Attorneys for Applicant(s)
P.O. Box 26927
Albuquerque, New Mexico 87125-6927

Telephone: (505) 998-1500
Facsimile: (505) 243-2542

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Customer No. 005179

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